RCE | 1765

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Docket No: Q61045

Group Art Unit: 1765

Examiner: Charlotte A. Brown

n re application of

Fumiyoshi ONO

Appln. No.: 09/672,776

Confirmation No.: 2256

Filed: September 29, 2000

For: COMPOSITION FOR POLISHING METAL ON SEMICONDUCTOR WAFER AND

METHOD OF USING SAME



Commissioner for Patents Washington, D.C. 20231

Sir:

Pursuant to 37 C.F.R. § 1.136, Applicant hereby petitions for an extension of time of two months, extending the time for responding to the Office Action of April 3, 2002, and the Advisory Action of August 12, 2002, from July 3, 2002 to September 3, 2002.

A check for the statutory fee of \$400.00 is attached. The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account. A duplicate copy of this sheet is enclosed.

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SUGHRUE MION, PLLC 2100 Pennsylvania Avenue, N.W. Washington, D.C. 20037-3213 Telephone: (202) 293-7060

Facsimile: (202) 293-7860

Date: September 3, 2002

Respectfully submitted,

Keiko K. Takagi

Registration No. 47,121

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q. No. 33725